

# Search Notes



Application/Control No.

10/725,864

Examiner

Stephen M. Hepperle

Applicant(s)/Patent under Reexamination

NAKAJIMA ET AL.

Art Unit

3753

## SEARCHED

Class	Subclass	Date	Examiner
137	484.8 505.18 505.37	10/05	SMA
429	22		
updated	search	5/06	SMA
429	25	8/06	SMA

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
see attached interference search sheet		8/06	SMA

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
CI 429—consulted Ex Ryan	10/05	SMA
EAST	10/05	SMA